

ORIO BELLEZZA
President, Global Technology and Manufacturing
STMicroelectronics

Orio Bellezza is STMicroelectronics' President, Global Technology and Manufacturing, and has held this position since July 2017. He has been responsible for Front-End Manufacturing since 2008 and later assumed additional responsibilities for technology R&D for automotive, industrial & multi-segment, and analog and power products. He is a member of ST's Executive Team.

Bellezza joined SGS-ATES, a predecessor company to STMicroelectronics, in 1984 as a fab process engineer. He soon moved to the Company's Central R&D organization and participated in several key projects, including the introduction of process technology modules for manufacturing sub-micron non-volatile memories. In 1996, Bellezza was appointed Director of ST's R&D facility in Agrate and led its upgrade and expansion into the Company's manufacturing and development center for non-volatile memory and smart-power technologies. In 2002, he became Vice President of Central R&D, and in 2005, was appointed to Vice President and Assistant General Manager of Front-End Technology and Manufacturing.

Bellezza has published technical papers and earned several patents in non-volatile memories.

Orio Bellezza was born in Bergamo, Italy, in 1959, and graduated cum laude with a degree in Chemistry from the University of Milan, Italy.

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